



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Min Kim et al.

Group Art Unit: 2822

Serial No.: 09/986,247

Examiner: Lewis, Monica

Filed: November 8, 2001

For: TRENCH ISOLATION STRUCTURE HAVING A CURVILINEAR INTERFACE AT UPPER CORNERS OF THE TRENCH ISOLATION REGION, AND METHOD OF MANUFACTURING THE SAME

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT


Honorable Commissioner of
Patents and Trademarks,
Washington, D.C. 20231

Sir:

In response to the Office Action of June 3, 2002, Applicants elect the invention of Group II, Claims 11-21, drawn to a method of manufacturing a trench isolation structure. The election is without traverse.

Respectfully submitted,

VOLENTINE FRANCOS, PLLC

for 

Adam C. Volentine
Registration No. 33,289

Reg # 33,581

12200 Sunrise Valley Drive, Suite 150
Reston, Virginia 20191
Telephone No.: (703) 715-0870
Facsimile No.: (703) 715-0877

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